

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Dureseti CHIDAMBARRAO

Group Art Unit : 2813

Appl. No. : 10/715,400

Examiner : J.M. Mitchell

Filed : November 19, 2003

Confirmation No. : 5307

For : SILICON DEVICE ON Si:C-OI AND SGOI AND METHOD OF
MANUFACTURE

AUTHORIZATION TO CHARGE DEPOSIT ACCOUNT

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Service Window, Mail Stop _____
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir :

The undersigned hereby authorizes the U.S. Patent and Trademark Office to charge any fees necessary to maintain the pendency of the above-identified application, including any basic filing fees, application size fees, search fees, examination fees, extension of time fees, and claim fees, to Deposit Account No. 09-0458.

Should the Examiner have any questions, the Examiner is invited to contact the undersigned at the below-listed telephone number.

Respectfully Submitted,
Dureseti CHIDAMBARRAO



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May 8, 2006
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